Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1 (Original) A method of manufacturing magnetic disks comprising a magnetic layer, a protective layer, and a lubricating layer on a substrate, in which

a lubricant alpha comprising a compound denoted by chemical formula

[Chem. 1]

wherein p and q are natural number,

and a compound denoted by chemical formula

[Chem. 2]

 $HO-CH_2-CF_2(-O-C_2F_4)m-(O-CF_2)n-O-CF_2-CH_2-OH$

wherein m and n are natural number,

is fractionated by molecular weight to prepare a lubricant a having a weight average molecular weight (Mw) of from 3,000 to 7,000 and a molecular weight dispersion of less than or equal to 1.2;

a lubricant beta comprising a compound denoted by the chemical formula

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[Chem. 3]

HO-CH₂-CF₂(-O-C₂F₄)m-(O-CF2)n-O-CF₂-CH₂-OH

wherein m and n are natural number,

is fractionated by molecular weight to prepare a lubricant b having a weight average molecular weight (Mw) of from 2,000 to 5,000 and a molecular weight dispersion of less than or equal to 1.2;

a lubricant c comprising a mixture of lubricants a and b is prepared; and a film of lubricant c is formed on a protective layer provided on a substrate to form a lubricating layer.

- 2 (Original) The method of manufacturing magnetic disks of claim 1, wherein the fractionation by molecular weight is conducted by supercritical extraction.
- 3 (Currently Amended) The method of manufacturing magnetic disks of claim 1 or 2, wherein lubricant c is prepared by obtaining a composition A of lubricant a dispersed in a fluorine-base solvent, obtaining a composition B of lubricant b dispersed in a fluorine-base solvent, mixing compositions A and B, and extracting lubricant c from the mixed composition.

- 4 (Currently Amended) The method of manufacturing magnetic disks of claim 1 any of claims 1 to 3, wherein after forming the lubricating layer, the resultant magnetic disk is exposed to an atmosphere of from 50 to 150°C to adhere lubricant c to the protective layer.
- 5. (Currently Amended) The method of manufacturing magnetic disks of <u>claim 1</u> any of claims 1 to 4, wherein the protective layer is formed by plasma CVD.
- 6 (Currently Amended) The method of manufacturing magnetic disks of <u>claim 1</u>

 any of claims 1 to 5, employed for load-unload system magnetic disk devices.
- 7 (Currently Amended) The method of manufacturing magnetic disks of <u>claim 1</u> any of claims 1 to 6, wherein Fomblin Ztetraol (product name) made by Solvay Solexis is selected as lubricant *alpha* and Fomblin Zdol (product name) made by Solvay Solexis is selected as lubricant *beta*.
- 8 (Original) A magnetic disk comprising a magnetic layer, a protective layer, and a lubricating layer on a substrate, in which the lubricating layer has been formed on the protective layer, said lubricating layer being comprised of a lubricant c,
 - comprising a lubricant a having a weight average molecular weight (Mw) of from 3,000 to 7,000 and a molecular weight dispersion of less than or

equal to 1.2 obtained by refining a lubricant *alpha* comprising the compound denoted by the chemical formula

[Chem. 4]

wherein p and q are natural number,
and a compound denoted by chemical formula

[Chem. 5]

 $HO-CH_2-CF_2(-O-C_2F_4)m-(O-CF_2)n-O-CF_2-CH_2-OH$

wherein m and n are natural number,

and a lubricant b having a weight average molecular weight (Mw) of from 2,000 to 5,000 and a molecular weight dispersion of less than or equal to 1.2, comprising a lubricant beta comprising a compound denoted by chemical formula

[Chem. 6].

HO-CH₂-CF₂(-O-C₂F₄)m-(O-CF2)n-O-CF₂-CH₂-OH wherein m and n are natural number.

9 (Original) A magnetic disk comprising a magnetic layer, a protective layer, and a lubricating layer on a substrate, in which the lubricating layer has been formed on the protective layer, said lubricating layer comprising a compound denoted by the chemical formula

[Chem. 7]

wherein p and q are natural number,

and a compound denoted by the chemical formula

[Chem. 8]

$$HO-CH2-CF2(-O-C2F4)m-(O-CF2)n-O-CF2-CH2-OH$$

wherein m and n are natural number,

and the lubricating layer contains -COOH atomic groups detectable by time of flight secondary ion mass spectrometry.

10 (Original) A magnetic disk comprising a magnetic layer, a protective layer, and a lubricating layer on a substrate, in which the lubricating layer comprises: a compound denoted by the chemical formula

[Chem. 9]

wherein p and q are natural number,

a compound denoted by the chemical formula

[Chem. 10]

wherein m and n are natural number,

and a compound having in its molecular structure -COOH atomic group detectable by time of flight secondary ion mass spectrometry.

11 (Currently Amended) The magnetic disk of <u>claim 8</u> any of claims 8 to 10, wherein the protective layer is a carbon-base protective layer.

12 (New) The magnetic disk of claim 9, wherein the protective layer is a carbon-base protective layer.

13 (New) The magnetic disk of claim 10, wherein the protective layer is a carbon-base protective layer.